EEMF 5283 Plasma Technology Laboratory (2 semester hours) Laboratory will provide a hands-on experience to accompany EEMF 5383. Topics to include: Vacuum technology [pumps, gauges, gas feed], plasma uses [etch, deposition, lighting and plasma thrusters] and introductory diagnostics. Corequisite: EE MF 5383. Recommended Corequisite: EEMF 7171. (0-2) R (2016-02-05 22:10:26)